

## *Supporting Information*

### **“Cage-Confinement” Controlled Dimensionality Conversion of Bi<sub>2</sub>O<sub>2</sub>Se Crystals towards High-Performance Phototransistors**

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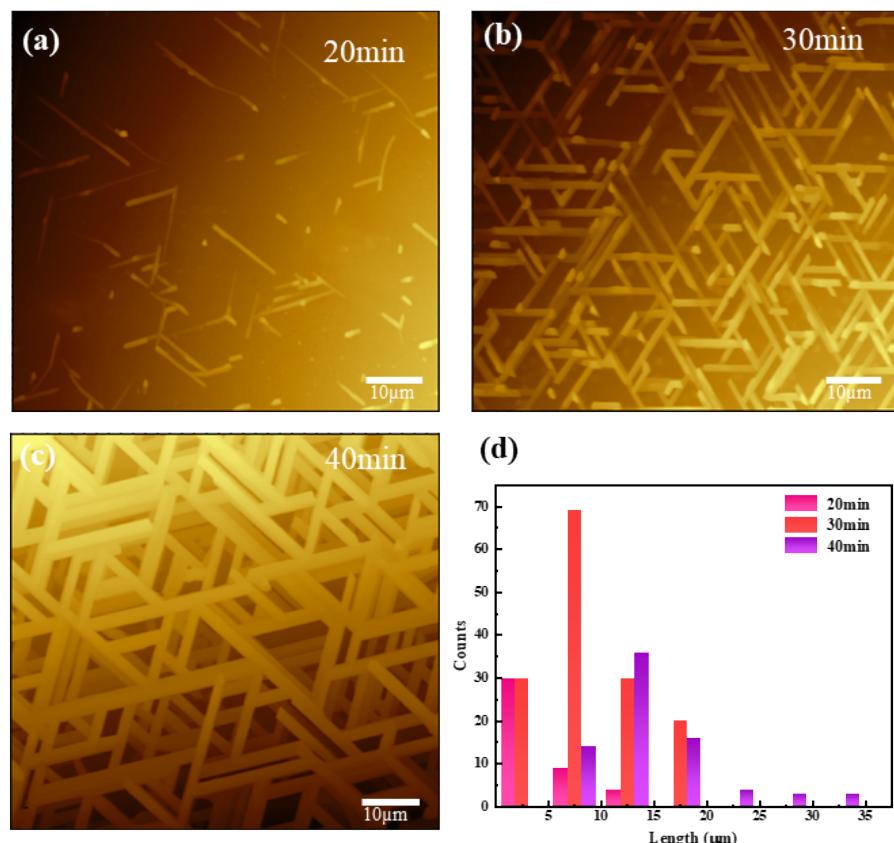
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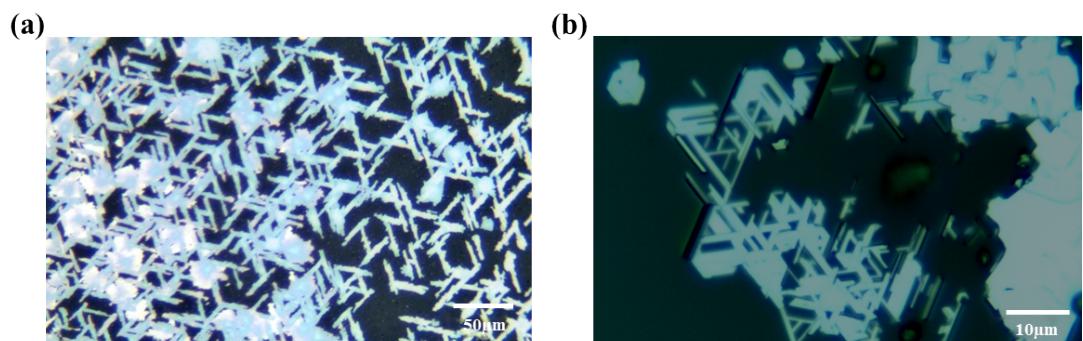
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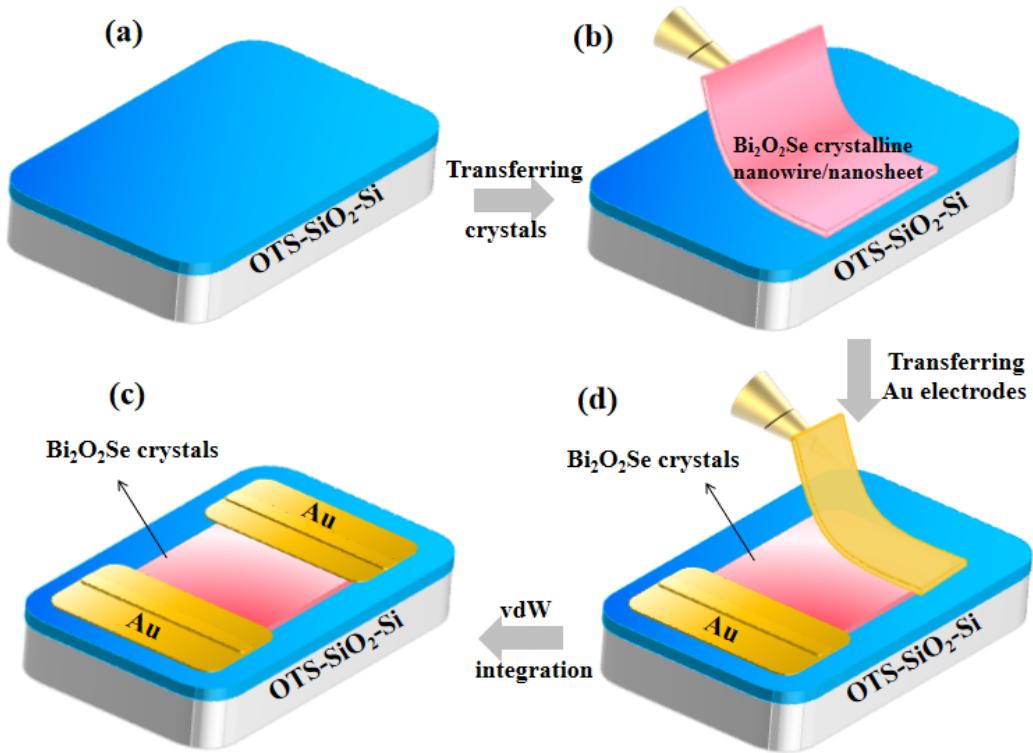
**Keywords:** Bi<sub>2</sub>O<sub>2</sub>Se crystal, controllable dimension, “cage-confinement” growth, van der Waals integrated technique, photodetectors



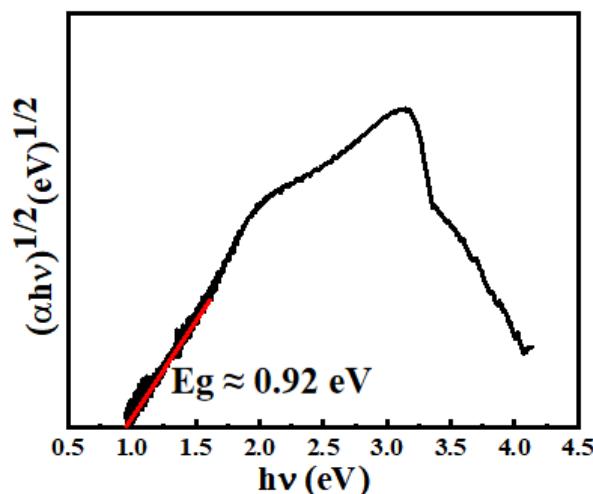
**Fig. S1.** AFM images of  $\text{Bi}_2\text{O}_2\text{Se}$  nanowires at different growth time. a) 20 min sample. b) 30 min sample. c) 40 min sample. d) Statistical diagram of  $\text{Bi}_2\text{O}_2\text{Se}$  nanowire lengths.



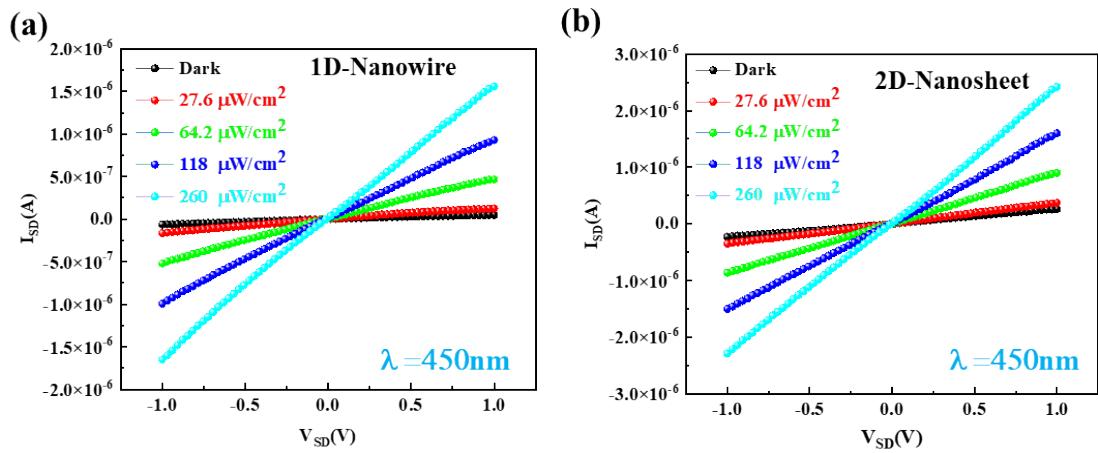
**Fig. S2.** OM images of  $\text{Bi}_2\text{O}_2\text{Se}$  crystals during the process of dimensional transformation (from 1D crystalline nanowires to 2D nanosheets). a)  $< 500 \mu\text{m}$  Active area with flow rate of  $\approx 100$  sccm. b)  $> 500 \mu\text{m}$  Active area with flow rate of  $\approx 50$  sccm.



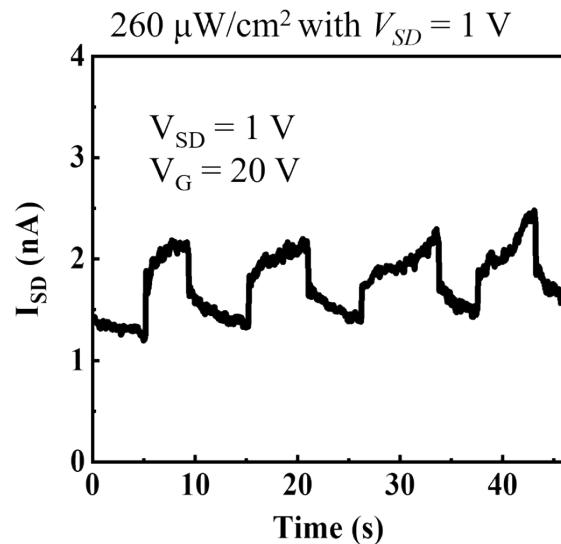
**Fig. S3.** Schematic illustration of the fabrication processes of Bi<sub>2</sub>O<sub>2</sub>Se-based FET. a) Incorporation of an OTS monolayer on the SiO<sub>2</sub> substrate. b) Mechanically transferring the Bi<sub>2</sub>O<sub>2</sub>Se single crystals with the help of probe. c) Stamping the source/drain electrodes onto the Bi<sub>2</sub>O<sub>2</sub>Se crystals with the help of probe. d) Schematic illustration of a bottom-gate-top-contact Bi<sub>2</sub>O<sub>2</sub>Se-based FET.



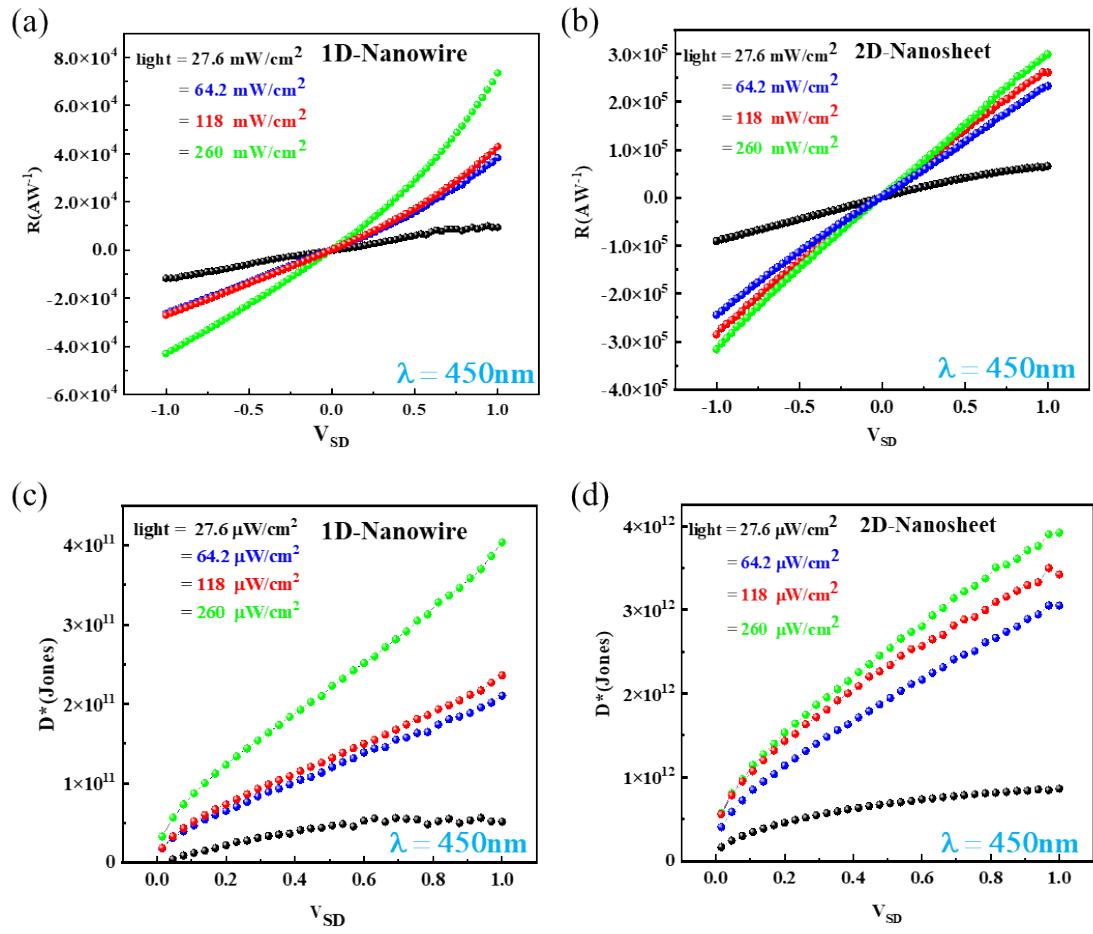
**Fig. S4.** Approximate value of Eg is calculated by a relationship known as the Tauc plot.



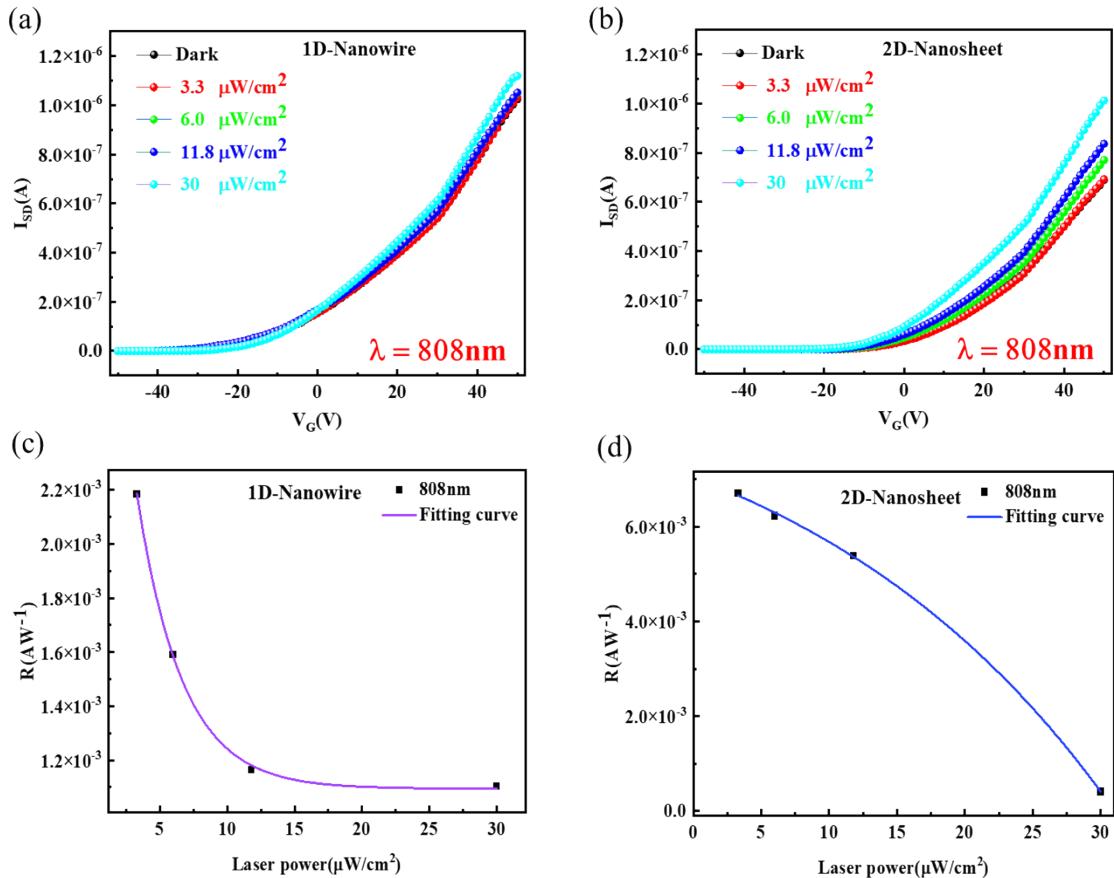
**Fig. S5.** (a, b) The  $I_{SD}$  output curves of 1D and 2D Bi<sub>2</sub>O<sub>2</sub>Se-based phototransistors under different light power densities conditions (measured at  $V_G = 60$  V and  $V_{SD} = 1$  V)



**Fig. S6.** Time-dependent photo-switching behaviors of Bi<sub>2</sub>O<sub>2</sub>Se nanoplate photodetector under the 450 nm laser illumination,  $P = 260$  mW/cm<sup>2</sup>, bias voltage  $V_{SD} = 1$  V and gate voltage  $V_G = 20$  V..



**Fig. S7.** (a, b) The  $R$  of  $\text{Bi}_2\text{O}_2\text{Se}$  nanowire/nanosheet devices at different light intensity levels, respectively. (c, d) The  $D^*$  of  $\text{Bi}_2\text{O}_2\text{Se}$  nanowire/nanosheet devices at different light intensity levels, respectively.



**Fig. S8.** (a, b) The  $I_{SD}$  transfer curves of 1D and 2D  $\text{Bi}_2\text{O}_2\text{Se}$ -based phototransistors under different light power densities conditions (measured at  $V_G = 60 \text{ V}$  and  $V_{SD} = 1 \text{ V}$ ). (c, d) The  $R$  of  $\text{Bi}_2\text{O}_2\text{Se}$  1D/2D devices at different light intensity levels, respectively.

**Table S1.** Comparison of the responsivity of present Bi<sub>2</sub>O<sub>2</sub>Se-based photodetectors.

Semiconductor	$\lambda$ (nm)	Responsivity (A/W)	Ref.
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	360	75.14	[1]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	360	108696	[2]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	365	2.068	[3]
Bi <sub>2</sub> O <sub>2</sub> Se nanoplate	400	523	[4]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	405	45134	[5]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	405	43	[6]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	405	50055	[2]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	500	1.2	[7]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	500	193	[7]
Bi <sub>2</sub> O <sub>2</sub> Se film	520	6.1	[8]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	532	$3 \times 10^3$	[9]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	532	$2 \times 10^3$	[10]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	532	$3.5 \times 10^4$	[11]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	532	45800	[12]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	532	60	[13]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	532	842.91	[14]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	532	25505	[2]
Bi <sub>2</sub> O <sub>2</sub> Se nanoribbon	590	$9.2 \times 10^6$	[15]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	635	44	[6]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	640	9.1	[16]
Bi <sub>2</sub> O <sub>2</sub> Se film	640	$3.8 \times 10^6$	[17]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	650	3.94	[3]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	660	22100	[9]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	808	6.5	[11]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	808	843.5	[2]
Bi <sub>2</sub> O <sub>2</sub> Se nanowire	808	722.2	[19]

Semiconductor	$\lambda$ (nm)	Responsivities (A/W)	Ref.
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	900	101	[18]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	940	300	[21]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	980	0.053	[3]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	1200	65	[22]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	1260	3.5	[07]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	1310	118	[2]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	1550	22.12	[2]
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	1550	58	[21]
Bi <sub>2</sub> O <sub>2</sub> Se nanowire	450	$3 \times 10^5$	This work
Bi <sub>2</sub> O <sub>2</sub> Se nanosheet	450	$7.4 \times 10^4$	This work

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